ication of: HI ANDO ET AL.

Docket No. 03500.014179.

FEB 2 4 2004

Application No.: 09/722,454

Filed: November 28, 2000

For: METHOD FOR MANUFACTURING ELECTRON BEAM DEVICE, METHOD FOR MANUFACTURING IMAGE FORMING APPARATUS, ELECTRON BEAM DEVICE AND IMAGE FORMING APPARATUS MANUFACTURED THOSE MANUFACTURING METHODS, METHOD AND APPARATUS FOR MANUFACTURING ELECTRON SOURCE, AND APPARATUS FOR MANUFACTURING IMAGE

FORMING APPARATUS

Examiner: M. Santiago

Group Art Unit: 2879

Date: February 9, 2004

THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) · HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	23	MINUS	181	0	x \$9 \$18	0	
INDEP. CLAIMS	11	MINUS	17	0	x \$43 \$86	0	
Fee for Multiple Dependent claims \$145°/\$290							
-	0.00						

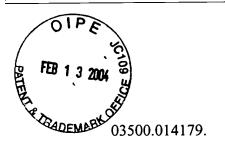
If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$\\$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
X	A check in the amount of \$\_110.00\] to cover the fee for a one- month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants
	Registration No. 7778

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

NY\_MAIN 406755v1



## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:	)	Examiner: M. Santiago
YOIC	CHI ANDO ET AL.	;	
Appli	ication No.: 09/722,454	;	Group Art Unit: 2879
Filed	: November 28, 2000	)	
For:	METHOD FOR MANUFACTURING ELECTRON BEAM DEVICE, METHOD FOR MANUFACTURING IMAGE FORMING APPARATUS, ELECTRON BEAM DEVICE AND IMAGE FORMING APPARATUS MANUFACTURED THOSE MANUFACTURING METHODS, METHOD AND APPARATUS FOR MANUFACTURING ELECTRON SOURCE, AND APPARATUS FOR MANUFACTURING IMAGE FORMING APPARATUS	: ) : ) : ) : ) : ) : )	FEB 2 4 2004 February 9, 2004
Mail	Ston Non-Fee Amendment		

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

Applicants petition to extend the time for response to the Office Action of October 7, 2003 to and including Saturday, February 7, 2004. A check in the amount of \$110.00 in payment of the extension fee is enclosed. Please charge any additional fee

02/18/2004 HALI11 00000053 09722454 01 FC:1251 110.00 DP I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 9, 2004.

(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)
(Name of Attorney for Applicant)

February 9, 2004

Date of Signature

and credit any overpayment to our Deposit Account 06-1205.

In response to the Office Action, please amend the above-identified application as follows.